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**Maximizing the thermoelectric performance of topological insulator  $\text{Bi}_2\text{Te}_3$  films in the few-quintuple layer regime** HUIJUN LIU, JINGHUA LIANG, LONG CHENG, JIE ZHANG, Wuhan University, ZHENYU ZHANG, University of Science and Technology of China — Using first-principles calculations and Boltzmann theory, we explore the feasibility to maximize the thermoelectric figure of merit ( $ZT$ ) of topological insulator  $\text{Bi}_2\text{Te}_3$  films in the few-quintuple layer regime. We discover that the delicate competitions between the surface and bulk contributions, coupled with the overall quantum size effects, lead to a novel and generic non-monotonous dependence of  $ZT$  on the film thickness. In particular, when the system crosses into the topologically non-trivial regime upon increasing the film thickness, the much longer surface relaxation time associated with the robust nature of the topological surface states results in a maximal  $ZT$  value, which can be further optimized to  $\sim 2.0$  under physically realistic conditions. We also reveal the appealing potential of bridging the long-standing  $ZT$  asymmetry of  $p$ - and  $n$ -type  $\text{Bi}_2\text{Te}_3$  systems. These findings help to establish intricate connections between the thermoelectric materials and topological insulators.

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